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Applicant Raaijmakers et al. Group Art Unit 2811 I hereby certify that this correspondence and all Appl. No. 09/452,844 marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Assistant Filed December 3, 1999 Commissioner for Patents, Washington, D.C. 20231, on CONFORMAL THIN FILMS For February 14, 2001 **OVER TEXTURED** CAPACITOR ELECTRODES Examiner C. Nyugen

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

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In an action mailed January 26, 2001, the Examiner required restriction of prosecution to one of the following groups of claims:

Group I Claims 36-54, drawn to a semiconductor device; and

Group II Claims 1-35 and 55-66, drawn to a method of making a semiconductor device.

In response to this restriction requirement, Applicants elect to proceed, without traverse, with prosecution on the merits of Group II (Claims 1-35 and 55-66), drawn to a method of making a semiconductor device.

Appl. No. Filed

09/452,844 December 3, 1999

Applicants submit that the application is in condition for examination on the merits, and respectfully request the same.

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: February 14, 2001

By:

Adeel S. Akhtar Registration No. 41,394 Attorney of Record 620 Newport Center Drive Sixteenth Floor Newport Beach, CA 92660 (415) 954-4114

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